



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Felton et al.**SERIAL NO:** 10/006,967**FILED:** 12/5/01**FOR:** METHOD AND DEVICE FOR PROTECTING MICRO ELECTROMECHANICAL SYSTEMS STRUCTURES DURING DICING OF A WAFER

Assistant Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop: Issue Fee**Sir:****CHANGE OF CORRESPONDENCE ADDRESS**

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Issue Fee

Deborah M. Costello

Date

5/11/04